

Electronic Patent Application Fee Transmittal

Application Number:	10613508			
Filing Date:	03-Jul-2003			
Title of Invention:	SELECTIVE ETCHING OF SILICON CARBIDE FILMS			
First Named Inventor/Applicant Name:	Di Gao			
Filer:	David Brian Raczkowski/Sushma Sanganeria-Brady			
Attorney Docket Number:	18062L-006400			
Filed as Small Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	2501	1	700	700
Publication fee for republication	1505	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1000